

Notice of References Cited	Application/Control No. 10/029,571	Applicant(s)/Patent Under Reexamination TAKAHASHI ET AL.	
	Examiner Carol S Tsai	Art Unit 2857	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2002/0002683 //	01-2002	Benson et al.	713/194
	B	US-5,956,415 //	09-1999	McCalley et al.	382/124
	C	US-2002/0195271 //	12-2002	Gailus, Mark W.	174/262
	D	US-2001/0033012 //	10-2001	Kommerling et al.	257/679
	E	US-6,436,735 //	08-2002	Goetz et al.	438/125
	F	US-6,421,013 //	07-2002	Chung, Kevin Kwong-Tai	343/700MS
	G	US-6,289,455 //	09-2001	Kocher et al.	713/194
	H	US-6,236,727 //	05-2001	Ciacelli et al.	380/212
	I	US-6,215,373. //	04-2001	Novak et al.	333/22R
	J	US-6,175,088. //	01-2001	Saccocio, Sean M.	174/262
	K	US-6,164,548 //	12-2000	Curiel, Yoram	235/487
	L	US-5,835,781 //	11-1998	Van de Steeg et al.	712/1
	M	US-5,369,299 //	11-1994	Byrne, Robert C.	257/638

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.